

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1765
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77903

Arie GLAZER, et al.

Appln. No.: 10/694,392

Group Art Unit: 1765

Confirmation No.: 9177

Examiner: Anita Karen ALANKO

Filed: October 28, 2003

For: SELECTABLE AREA LASER ASSISTED THERMAL PROCESSING OF TFT
SUBSTRATES

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 12, 2006, please amend the above-identified application as follows on the accompanying pages.